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PATENT

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Docket No.: 2328-062

EXPEDITED PROCEDURE

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Response under 37 CFR 1.116

DHINDSA, Rajinder et al.

Confirmation No.

8414

U.S. Patent Application No. 10/645,665

Group Art Unit: 2821

Filed: August 22, 2003

Examiner: TUNG X LE

For: MULTIPLE FREQUENCY PLASMA ETCH REACTOR

AMENDMENT UNDER RULE 116

Commissioner for Patents PO Box 1450 Alexandria, VA 22313-1450

Sir:

This paper is submitted in reply to the Office Action mailed January 14, 2008, which was made Final. Applicants respectfully request that the following amendments as to form be entered to place this application in condition for allowance.

CERTIFICATION OF FACSIMILE TRANSMISSION

I HEREBY CERTIFY THAT THIS PAPER IS BEING FACSIMILE TRANSMITTED TO THE PATENT AND TRADEMARK OFFICE

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